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Attorney Docket SEL 203

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of )  
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NAKAJIMA et al. )  
)  
Serial No.: 09/635,945 )  
)  
Filed: August 10, 2000 )  
)  
For: Semiconductor Device And Method )  
Of Manufacturing The )  
Semiconductor Device )  
)  
)  
Art Unit: 2811 )  
)  
Examiner: S. Hu )

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents , P.O. Box 1450, Alexandria, VA 22313-1450 on <u>February 9 2005</u> (Date of Deposit) <u>Shannon Wallace</u> Name of applicant, assignee, or Registered Rep. <u>Shannon Wallace</u> <u>2/9/05</u> Signature Date	
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Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT G (AFTER FINAL)**

In response to the Final Rejection of November 10, 2004, please enter the following amendment in the above-identified application: